



#10/B
(N.E.)

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Gurtej S. Sandhu

Serial No.: 09/023,146

Filed: February 12, 1998

**For: TUNGSTEN SILICIDE (WSIx)
DEPOSITION PROCESS FOR
SEMICONDUCTOR MANUFACTURE**

Examiner: T. Dang

Group Art Unit: 2823

**Attorney Docket No.: 3369US
(91-365-RE)**

CERTIFICATE OF MAILING

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Devin R. Jensen
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AMENDMENT UNDER 37 C.F.R. §1.116

Box AF
Assistant Commissioner for Patents
Washington, D.C. 20231

Sir:

The following amendments and remarks are filed in response to the Examiner's remarks in the Final Office Action mailed December 28, 1999, the three-month shortened statutory period for response to which expires on March 28, 2000. This response is submitted on or before two months from the mailing date of the Final Office Action.